

Course Schedule, group M19-482**MONDAY**

12:45 — 14:20	■ LEC	Elect	Physics and Sensor Technology	🎓 Kotkovskiy G.E.	📍 DOT
14:30 — 16:05	■ SEM	Elect	Physics and Sensor Technology	🎓 Kotkovskiy G.E.	📍 DOT

TUESDAY

11:05 — 12:40	■ LEC	Elect	Reliability and Radiation Resistance of Microelectronic Devices and Systems	🎓 Zebrev G.I.	📍 DOT
12:45 — 14:20	■ SEM	Elect	Reliability and Radiation Resistance of Microelectronic Devices and Systems	🎓 Zebrev G.I.	📍 DOT
	■ LEC	Elect	Organic Photovoltaics	🎓 Nikitenko V.R.	📍 DOT
14:30 — 16:05	■ SEM	Elect	Organic Photovoltaics	🎓 Saunina A.Y., Nyunzi D., Nikitenko V.R.	📍 DOT

WEDNESDAY

14:30 — 16:05	■ LEC		Design of Integrated Circuits and Systems-on-Chip (SOC)	🎓 Bakerenkov A.S.	📍 DOT
16:15 — 17:50	■ SEM		Design of Integrated Circuits and Systems-on-Chip (SOC)	🎓 Bakerenkov A.S.	📍 DOT
18:45 — 20:20	■ LAB		Design of Integrated Circuits and Systems-on-Chip (SOC)	🎓 Bakerenkov A.S.	📍 DOT

THURSDAY

11:55 — 13:30	■ LEC		Physics of Nanosystems (2020-09-03 — 2020-10-15)	🎓 Sibirmovskiy Y.D., Vasilievskiy I.S.	📍 DOT
	■ LEC		Physics of Nanosystems (2020-10-29 — 2020-12-10)	🎓 Sibirmovskiy Y.D.	📍 DOT
	■ LEC		Physics of Nanosystems	🎓 Sibirmovskiy Y.D.	📍 DOT
13:35 — 15:15	■ SEM		Physics of Nanosystems	🎓 Sibirmovskiy Y.D., Vasilievskiy I.S.	📍 DOT

FRIDAY

09:20 — 11:00	■ LEC		Nanophotonics	🎓 Freydzon A.Y.	📍 DOT
11:05 — 12:40	■ SEM		Nanophotonics	🎓 Freydzon A.Y.	📍 DOT
12:45 — 13:30	■ LAB		Nanophotonics	🎓 Freydzon A.Y.	📍 DOT
14:30 — 16:05	■ LEC	Elect	Process Description Methods in Nanoparticle Ensembles (Self-assembly)	🎓 Lebedev-Stepanov P.V.	📍 DOT
16:15 — 17:50	■ SEM	Elect	Process Description Methods in Nanoparticle Ensembles (Self-assembly)	🎓 Lebedev-Stepanov P.V.	📍 DOT